



Pct. Dec.

UNITED STATES PATENT AND TRADEMARK OFFICE

Technology Center 1700

Mailed: 4/19/05

MEB
Paper Number:

In re application of
Kevin J. Lee
Serial No. 09/223,472
Filed: December 30, 1998
For: Electroplating Cell Based Upon Rotational Plating
Solution Flow

:
:
:
:
:
:

DECISION ON
PETITION

This is a response to the request to rescind the Notice of Abandonment, mailed November 16, 2004. This request is treated as a PETITION TO WITHDRAW ABANDONMENT, under 37 C.F.R. 1.181 (no fee required). The petition requests that the abandonment, as set forth in the Notice of Abandonment of November 16, 2004, for failure to timely reply to the Board of Appeals decision of September 2, 2004, be withdrawn. The petitioner asserts that the response was timely filed on November 2, 2004.

DECISION

USPTO records show that an appropriate response to the Board of Appeals decision of September 2, 2004 was filed with the office on November 5, 2004, with a Certificate of Mailing date of November 2, 2004, thus making the response timely. The application will be forwarded to the examiner for processing and consideration of the papers filed November 5, 2004.

The Petition is **Granted**.



UNITED STATES PATENT AND TRADEMARK OFFICE

Technology Center 1700

J. Stone

Jacqueline Stone, Director
Technology Center 1700
Chemical and Materials Engineering

Mark A. Kupanoff
Blakely, Sokoloff, Taylor & Zafman LLP
12400 Wilshire Blvd.
Seventh Floor
Los Angeles, CA 90025-1030